



Filed Via Express Mail

Rec. No.: EV 332 248 083 US

On: MARCH 31, 2004

By: 

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

Attorney Docket No.: NECK 17.552 (100806-17282)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi TANABE
Serial No.: 09/614,286
Filed: July 12, 2000
Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS
AT DESIRED POSITIONS ON A SUBSTRATE**
Examiner: Erik J. Kielin
Group Art Unit: 2813

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

S I R :

Applicant requests that the time for taking action in this case be extended pursuant to 37 CFR 1.136(a) for:

☐ one month ☒ **three months**

☐ two months ☐ four months

The fee set in 37 CFR 1.17 for the extension of time is \$950.00.

04/02/2004 AWONDAF1 00000076 501290 09614286

02 FC:1253 950.00 DA

11110642.02

☐ Fee enclosed. Please charge any additional fee required for this extension of time to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.

☒ **Charge fee to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.**

☐ Applicant is a small entity entitled to pay reduced fees in this application. A verified small entity statement:

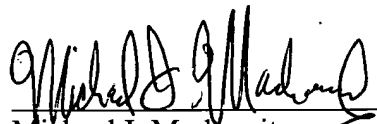
☐ has been filed ☐ is enclosed

Also enclosed is a:

☒ **Response to Official Action**

☐ Notice of Appeal ☐ Appeal Brief

Respectfully submitted,


Michael I. Markowitz
Reg. No. 30,659

CUSTOMER NO.: 026304

Phone No.: (212) 940-8687

Fax No.: (212) 940-8986/7

ATTORNEY DOCKET NO.:NECK 17.552

MIM:lh